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In re the Application of: YAMAGISHI, Yasuo, et al.

Group Art Unit: 2829

Serial No.: 10/621,445

Examiner: Jermele M. HOLLINGTON

Filed: July 18, 2003

P.T.O. Confirmation No.: 1112

For:

PROBE CARD AND TESTING METHOD OF SEMICONDUCTOR CHIP,

CAPACITOR AND MANUFACTURING METHOD THEREOF

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

January 27, 2006

Sir:

In response to the Office Action dated **November 7, 2005**, please amend the above-identified application as follows: